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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Yuuichi KAWAGUCHI et al.
Appl. No. : 10/786,006
Filed : February 26, 2004
For : METHOD OF FORMING A RESIST PATTERN AND RESIST PATTERN FORMING APPARATUS

Group Art Unit : 1756
Examiner : Not Yet Assigned
Confirmation No. : 3838



INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir :

In accordance with the duty of disclosure under 37 C.F.R. §1.56 and §§1.97-1.98,
Applicants hereby call to the Examiner's attention the following document:

Japanese Laid-Open Patent Publication No. 2000-11465, which was published on
January 14, 2000, together with an English language Abstract of the same. Applicants
note that this document is mentioned on page 1 of the specification of the present
application.

Applicants respectfully request that the Examiner consider the above material and
cite the same. A copy of the above-noted material is attached hereto and is listed on the
attached PTO-1449 Form. The Examiner is requested to initial the appropriate spaces on
the attached Form and to return a copy of the completed Form to Applicants with the next
official communication in the present application.

Applicants also bring to the Examiner's attention the following co-pending, commonly assigned patent application:

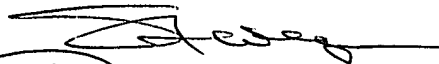
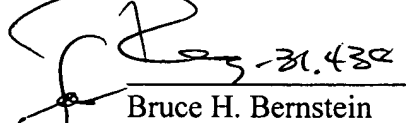
U.S. Patent Application No. 10/801,689 to NAKADA et al., entitled "Resist Pattern Forming Method and Resist Pattern Forming System," which was filed on March 17, 2004.

In accordance with 37 C.F.R. §1.98 (a)(2)(iii), a copy of the above-noted application is attached. The Examiner is requested to review the file wrapper of the U.S. patent application at the U.S. Patent and Trademark Office and the references of record, if any, cited therein.

Applicants notes that an Office Action on the merits has not issued in the present application, and thus no fee is believed necessary to ensure consideration of the submitted material.

Should the Examiner have any questions, the Examiner is invited to contact the undersigned at the below-listed telephone number.

Respectfully Submitted,
Yuuichi KAWAGUCHI et al.



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May 25, 2004
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Application No.
10/786,006

Group
1756

[illegible][illegible]

		1	English Language Abstract of JP 2000-11465.

DATE CONSIDERED

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.